

Notice of References Cited

Application/Control No.

10/718,083

Applicant(s)/Patent Under

Reexamination

KIM ET AL.

Examiner

Camie S Thompson

Art Unit

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*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
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	B	US-6,211,369	04-2001	Salbeck et al.	546/18
	C	US-			
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	K	US-			
	L	US-			
	M	US-			

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	N	CN1338499	03-2002	China	Li et al	
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
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